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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

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In re application of: Koemtzopoulos et al.

Attorney Docket No.:

LAM1P186/P1211

Application No.: 10/803,342

Examiner: Alanko, Anita K.

Filed: March 17, 2004

Group: 1792

Title: DUAL DOPED POLYSILICON AND  
SILICON GERMANIUM ETCH

Confirmation: 5586

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CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on June 26, 2009.

Signed: \_\_\_\_\_/Laura M. Dean/  
Laura M. Dean

**AMENDMENT C**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 1, 2009 please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.